MAIL STOP AF
RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2851

00862.023098

PATENT APPLICATION

IN THE UNITED STATES PAT	ENT A	AND TRADEMARK OFFICE	
In re Application of:)	Examiner: K. Gutierrez	O W CONT
YOSHIKAZU MIYAJIMA)	C	
Application No.: 10/647,376 Filed: August 26, 2003	;) ;)	Group Art Unit: 2851 Confirmation No.: 2042	2CE
For: REFLECTION MIRROR APPARATUS, EXPOSURE APPARATUS AND DEVICE MANUFACTURING METHOD	;	March 5, 2007	4/5/00 pm

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Official Action mailed January 5, 2007, the

Examiner is respectfully requested to consider and enter the following amendments.